

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	61	(sic or (silicon adj carbide)) same (induction) same (heating or (high adj energy) or thermal\$2) same wafer	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/04/18 03:40
L2	130	((sic or (silicon adj carbide)) same wafer same (impurity or dopant or doping or implant\$5) ) and (induction)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/04/18 03:52

4/ 18/ 08 4:04:37 AM

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